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| | | Application Number | 10/698,178 | | |
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i> | | Filing Date | 10/31/2003 | | |
| | | Applicant(s) | UDESHI et al. | | |
| | | Art Unit | 2168 | | |
| | | Examiner Name | ONI, Olubusola | | |
| | | SHEET | 1 | OF | 1 |

| U. S. PATENT APPLICATION PUBLICATIONS | | | | |
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| Examiner's Initials | Cite No. | Document Number | Publication Date MM/DD/YYYY | Name of Patentee or Applicant of Cited Document |
| | BA | 20010044327 | 11/22/2001 | Karefsky |
| | BB | 20020027563 | 03/07/2002 | Van Doan et al. |
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| | BD | 20030187867 | 10/02/2003 | Smartt |
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| Examiner's Initials | Cite No. | Foreign Patent Document (Country Code - Number - kind) | Publication Date MM/DD/YYYY | Patentee or Applicant of Cited Document | Translation Y/N |
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| NON-PATENT LITERATURE DOCUMENTS | | |
|---------------------------------|----------|--|
| Examiner's Initials | Cite No. | Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published |
| | DA | CHANG et al., "LDI: a Hierarchical Representation for Image-Based Rendering", May 1999, ACM Special Interest Group on Computer Graphics and Interactive, Pages 291-298. |
| | DB | PRATT, "Direct Least-Squares Fitting of Algebraic Surfaces", Computer Graphics, Volume 21, Number 4, July 1987. |
| | DC | WILHELMSEN et al., "Octrees for Faster Isosurface Generation", July 1992, ACM Press, Volume 22, Issue 3, Pages 201-227. |
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| Examiner Signature | Date Considered |
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